



RESPONSE AFTER FINAL
EXPEDITED PROCEDURE
GROUP 2814
PATENT APPLICATION

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of

Docket No: Q79450

Masayuki NAYA, et al.

Appln. No.: 10/766,018

Group Art Unit: 2814

Confirmation No.: 2668

Examiner: Marcos D. Pizarro-Crespo

Filed: January 29, 2004

For: SENSOR CHIP, PROCESS FOR PRODUCING THE SAME, AND SENSOR USING
THE SAME

REQUEST FOR RECONSIDERATION

MAIL STOP AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated June 14, 2006, please consider the remarks as
follows on the accompanying pages.

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